



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

EP 2813  
PATENT  
part of  
6

In re Application of:

Ravi Iyer

Serial No.: 09/059,865

Filed: April 14, 1998

For: PLANARIZATION USING PLASMA  
OXIDIZED AMORPHOUS SILICON

§  
§ Group Art Unit: 2813  
§  
§  
§  
§ Examiner: Nguyen, T.  
§  
§  
§  
§ Atty Docket: MICS:0015--2/FLE  
§ 93-118.02

Assistant Commissioner  
for Patents  
Washington, D.C. 20231

CERTIFICATE OF TRANSMISSION AND MAILING  
37 C.F.R. 1.8

I hereby certify that this correspondence is being transmitted by facsimile to the United States Patent and Trademark Office in accordance with 37 C.F.R. 1.6(d) and is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on the date below:

December 3, 1998

Date

Michael G. Fletcher

Sir:

**REDIRECTION OF CORRESPONDENCE**

Please direct all future correspondence for the above-referenced patent application to the following:

Michael G. Fletcher  
Fletcher, Yoder & Van Someren  
P.O. Box 692289  
Houston, Texas 77269-2289  
(281) 970-4545

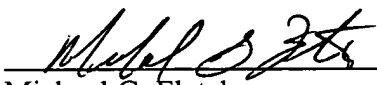
RECEIVED

DEC 10 1998

GROUP 2100

Respectfully submitted,

Dated: December 3, 1998

  
Michael G. Fletcher  
Reg. No. 32,777  
FLETCHER, YODER & VAN SOMEREN  
P.O. Box 692289  
Houston, Texas 77269-2289  
(281) 970-4545